



Pillsbury  
Winthrop  
Shaw  
Pittman LLP

2475 Hanover Street  
Palo Alto, CA 94304-1114  
Tel 650.233.4500  
Fax 650.233.4545  
www.pillsburylaw.com

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## Comments:

In re application of: CHANG SEO PARK, et al.  
Application Serial No.: 10/826,665  
Filed: 04/16/2004  
Confirmation No.: 9608  
Group No.: 2813  
Examiner: Harrison, Monica D.

Title: METHOD TO FABRICATE CMOS DEVICE WITH DUAL METAL  
GATE ELECTRODES

Attached: Status Inquiry (1 page)

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PATENT

Attorney's Docket No. 061472-0308425

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: CHANG SEO PARK, et al.

Confirmation No.: 9608

Application No.: 10/826,665

Group No.: 2813

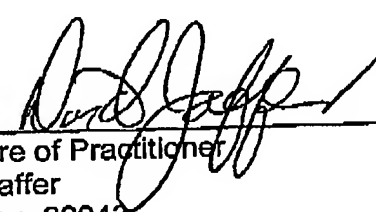
Filed: 04/16/2004

Examiner: Harrison, Monica D.

For: METHOD TO FABRICATE CMOS DEVICE WITH DUAL METAL GATE  
ELECTRODESCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

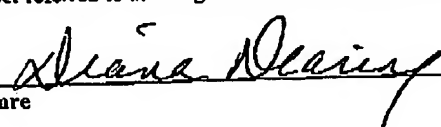
## STATUS INQUIRY

1. More than four months have passed since the filing of a response on February 27, 2007.
2. On May 24, 2007, I spoke with Examiner Harrison regarding this application. She stated that she would withdraw the final Office Action and issue a non-final Office Action allowing all claims except for claims 16-18 with a discussion of that rejection.
3. We have not yet received that new Office Action.
4. Kindly advise the undersigned as to when we might expect the new non-final Office Action.

Date: June 17, 2007PILLSBURY WINTHROP SHAW  
PITTMAN LLP  
2475 Hanover Street  
Palo Alto, CA 94304-1114  
Customer No.: 27498  
Signature of Practitioner  
David Jaffer  
Reg. No.: 32243  
Tel. No.: (650) 233.4510

## CERTIFICATION UNDER 37 C.F.R. §§ 1.8 and/or 1.10\*

I hereby certify that, on the date shown below, this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office, (571) 273-8300.

Date: 6-18, 2007  
Signature

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